

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10628174			
<b>Filing Date:</b>	28-Jul-2003			
<b>Title of Invention:</b>	PROCEDURE FOR ETCHING OF MATERIALS AT THE SURFACE WITH FOCUSED ELECTRON BEAM INDUCED CHEMICAL REACTION AT SAID SURFACE			
<b>First Named Inventor/Applicant Name:</b>	Hans Wilfried Peter Koops			
<b>Filer:</b>	Kenneth Lowell Mitchell/Karl Kurple			
<b>Attorney Docket Number:</b>	8183			
Filed as Large Entity				
<b>Utility under 35 USC 111(a) Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Extension-of-Time:</b>				
<b>Miscellaneous:</b>				
Printed copy of patent - no color	8001	5	3	15
<b>Total in USD (\$)</b>				<b>1825</b>